



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. ....09/881,408  
Confirmation No.....8492  
Filing Date ..... June 13, 2001  
Inventor..... Kie Y. Ahn, et al  
Assignee..... Micron Technology, Inc.  
Group Art Unit.....2814  
Examiner .....T. Le  
Attorney's Docket No. ....MI22-1534  
Customer No. ....021567  
Title: A Dielectric Layer Forming Method and Devices Formed Therewith

**RESPONSE TO NOVEMBER 19, 2003 OFFICE ACTION**

To: Commissioner for Patents  
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Art Unit 2814  
Alexandria, VA 22313-1450

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**AMENDMENTS**

No amendments.

EL979954315